

Docket: CU-3453

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application: Jin Hui Cho et al.

GRP ART UNIT: 2871

Serial No: 10/713,883

Ex.: A.M. Schechter

Filed: November 14, 2003

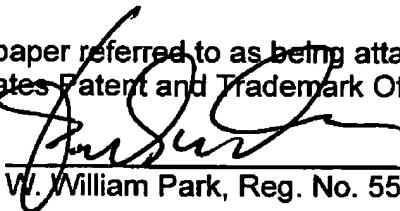
RECEIVED  
CENTRAL FAX CENTER  
MAY 19 2005

For: Method for Manufacturing Transflective Thin Film  
Transistor (TFT) Liquid Crystal Display (LCD)**Certification under 37 C.F.R. §1.8(a)**

The USPTO Central Fax No. (703) 872-9306

Date of Fax Transmittal: May 19, 2005

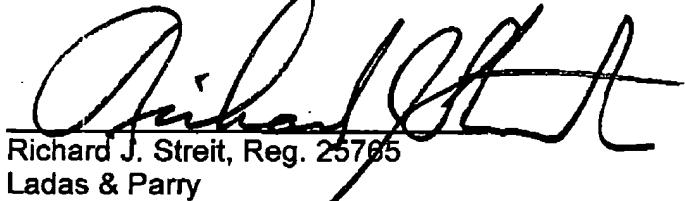
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.

  
 W. William Park, Reg. No. 55,523
The Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**AUTHORIZATION TO ACT IN A REPRESENTATIVE CAPACITY**

The practitioner **Woochoon William Park, Reg. No. 55,523** is authorized to conduct interviews and has the authority to bind the principal concerned. Further, the practitioner is authorized to file correspondence in the above-identified application pursuant to 37 CFR 1.34, including to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

The practitioner named above does not have the authority to sign a request to change the correspondence address, a request for an express abandonment, a disclaimer, a power of attorney, or other document requiring the signature of the applicant, assignee of the entire interest or an attorney of record. If appropriate a separate Power of Attorney to the above named practitioner should be executed and filed in the United States Patent and Trademark Office.

Respectfully submitted,

  
 Richard J. Streit, Reg. 25765  
 Ladas & Parry  
 224 South Michigan Avenue  
 Chicago, Illinois 60604  
 (312) 427-1300
Dated: May 19, 2005